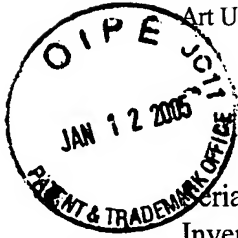


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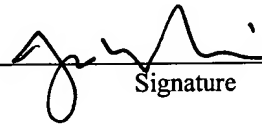


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

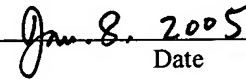
Serial No.: **10/695,106** Examiner: **Phuc T. Dang**
Inventor: **Hong Hocheng and Yun-Liang Huang**
Filed: **October 27, 2003** Art Unit: **2818**
Title: **A Method For Detecting The Endpoint Of A Chemical Mechanical Polishing (CMP) Process**

Certificate of Mailing

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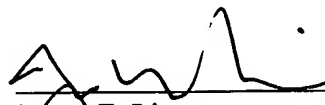
SUBMISSION OF FORMAL DRAWINGS

Honorable Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450
Attn.: Official Draftsperson

Sir:

Enclosed are **six** sheets of the formal drawings for FIGs. **1-6** for correcting informalities and filing in the above-identified U.S. patent application.

Respectfully submitted,



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